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A B S T R A C T

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5 An electronic device manufacturing apparatus
includes a gas removal means for removing a gas
dissolved in a liquid containing the formation material
of a member constituting an electronic device, a
droplet discharge means for discharging droplets of the
liquid, and a means for controlling the relative
positions of the droplet discharge means and a
substrate on which the electronic device is formed.
0 The droplets are applied to a predetermined position on
the substrate. The gas removal means includes a closed
vessel filled with a membrane formed from a
semi-transmitting film capable of transmitting a gas,
and a vacuum unit for evacuating the closed vessel.

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